

RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2818

PATENT APPLICATION  
Docket. No.: 2522-055  
Client Ref. No.: AW9010US/PJ

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Ju-Chool SHIN, et al.

Serial No.: 10/816,989 Examiner: Lee, Calvin

Filed: April 1, 2004 Group Art Unit: 2818

Confirmation No.: 2017

For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

This paper is responsive to the Final Office Action (Paper No. 6) that was mailed on 9 June 2006.

**Claim Amendments** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.